

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of: SINGH, et al.

Application No.: 10/081,979

Examiner:

Date Filed: February 22, 2002

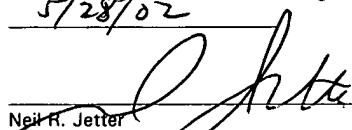
Group:

For: IMPROVED CHEMICAL-MECHANICAL POLISHING SLURRY FOR
POLISHING OF COPPER OR SILVER FILMS



CERTIFICATE UNDER 37 CFR 1.8(a)

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class mail in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231, on

5/28/02

Neil R. Jetter Reg. No. 46,803

TRANSMITTAL LETTER

Commissioner for Patents
Washington, DC 20231

Sir:

Please find enclosed for filing the following documents:

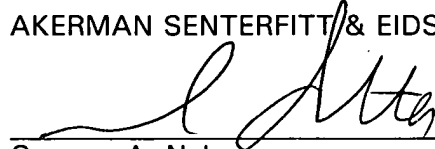
- ✓ Information Disclosure Statement, PTO-1449, references; and
- ✓ 1 Postcard

Although no fee is believed due, please charge any underpayment to Deposit Account No. 50-0951. This letter is submitted in duplicate.

Respectfully submitted,

AKERMAN SENTERFITT & EIDSON, P.A.

Dated: 5/28/02


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Docket No. 5853-223

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